

# Search Notes



Application/Control No.

10/604,641

Examiner

José V. Chen

Applicant(s)/Patent under Reexamination

PONZIO, MASSIMO

Art Unit

3637

## SEARCHED

Class	Subclass	Date	Examiner
100	55.1	3/22/06	SV
	55.3		
	51.11		
198	803.11		
	803.01		
269	56		
	53		
	292		
<del>100</del>		<del>10/17/06</del>	<del>SV</del>

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
Pa & Base Sources Re Base Pat	3/22/06	SV
<del>100</del>	<del>10/17/06</del>	<del>SV</del>